INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 9, 2026

IGI Report Number	LG833695864
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	6.44 X 6.38 X 4.39 MM

GRADING RESULTS

Carat Weight	1.52 CARAT
Color Grade	E
Clarity Grade	VS 1
Cut Grade	EXCELLENT

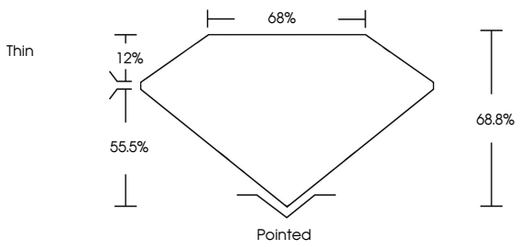
ADDITIONAL GRADING INFORMATION

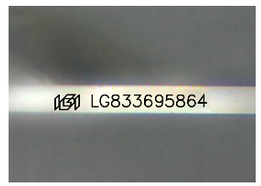
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG833695864

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG833695864
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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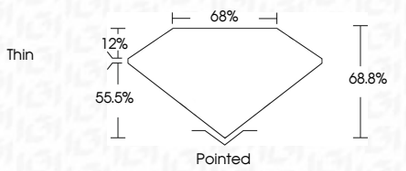
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www.igi.org

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IGI

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PRINCESS CUT
6.44 X 6.38 X 4.39 MM
Carat Weight 1.52 CARAT
Color Grade E
Clarity Grade VS 1
Cut Grade EXCELLENT
Depth 68.8%
Table 68%
Girdle Thin
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG833695864
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Type IIa